

# Singapore Technical Seminar-Frontend



Technical  
Leadership  
Program



# CERTIFICATE OF ACHIEVEMENT

This certificate is awarded to

**John Saw**

in recognition of the paper

*Hardware Modifications & Process Characterizations  
on FOAK NT333 Spatial ALD Nitride Platform  
for RG Unique Blocking Oxide Layer*

presented November 11, 2020 at the

**2020 Micron-TLP  
Singapore Technical Seminar-Frontend**

A blue ink signature, likely of Kok Sing Chen, written over a horizontal line.

Kok Sing Chen, Corporate Vice President & Country Manager